

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Toru Kimura et al.	Confirmation No.: 4887
Application No.:	10/586,187	Group Art Unit: 1722
Filed:	July 31, 2007	Examiner: JOHNSON, CONNIE P.
Attorney Docket No.: 01115_1013		

For: UPPER LAYER FILM FORMING COMPOSITION FOR LIQUID IMMERSION
AND METHOD OF FORMING PHOTORESIST PATTERN

MAIL STOP AF
Commissioner for Patents
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.116

Dear Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated September 22, 2010.

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